Professor Wang's Presentation [Placeholder Text]

Placeholder Text

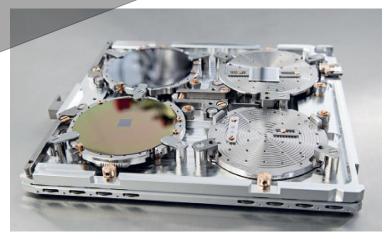
University of Minnesota

Department of Electrical & Computer Engineering



Table of Contents

- I. Background & Motivation.
- II. Electron-Beam Lithography vs. 3D Printing vs. CNC Nathining.
- III. Design Process Flow.
- IV. Maskless Direct Writing.
- V. Equipment Advantages & Disacrantages.
- VI. Example Chips
- VII. Sonclusion



Raith Nanofabrication, Multi-Sample Holder (2022)

